



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81015

Shuho MOTOMURA

Appln. No.: 10/820,752

Group Art Unit: 1762

Confirmation No.: 8798

Examiner: Katherine BAREFORD

Filed: April 9, 2004

For: SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

&

RESPONSE TO RESTRICTION REQUIREMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 12, 2006, please amend the above-identified application as follows on the accompanying pages.